



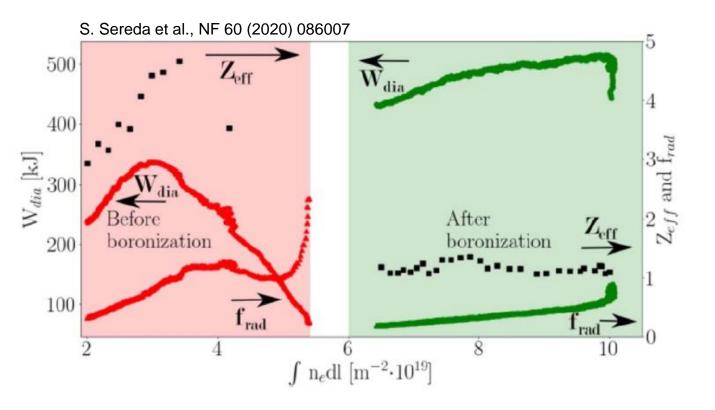
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## Boronizations are key point to successful plasma operation

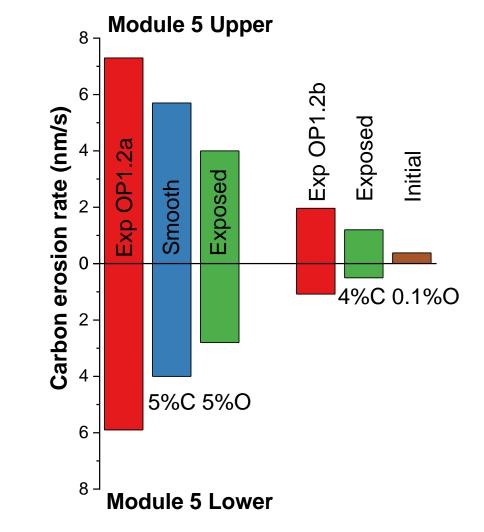


- Boronizations in OP1.2b resulted in decrease of O concentration by factor ~50
- Decrease of O concentration results on decrease of TDU erosion by factor ~5

## $\rightarrow$ Key point to successful plasma operation

## Peak erosion rate at TDU strike line

Wendelsteir



M. Mayer et al., NME 34 (2023) 101352

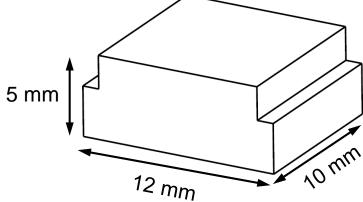
# Work in 2023: Sample exposures using multi-purpose manipulator in OP 2

## Samples: Material qualified, manufactured, pre-characterised

- Fine-grain graphite, polished and unpolished
- Aluminium
- Aluminium with 7 or 30 nm a-C:D

## Planned exposured with multi-purpose manipulator

- (Carbon erosion during glow-discharge cleaning)
- Boron deposition during boronizations
- · Carbon erosion during selected discharges in far scrape-off layer
- Hydrogen deposition and charge-exchange fluxes in selected discharges in far scrape-off layer
- Tungsten deposition and transport using laser blow-off

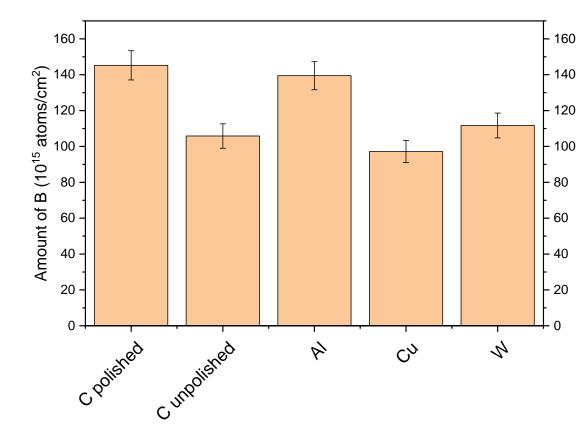




## Boronization on 4.2.2023



- Amount of B 10 15 nm
- No material dependence, about identical from C to W
- Thicker on polished surfaces than on unpolished → ???
- Homoeopathic amounts of B have large effect
  → Large surface area of 200 m<sup>2</sup> inside W7-X



## Midplane manipulator: Charge-exchange fluxes and energies



- Exposure of catcher plates (graphite, AI, ...) with midplane manipulator during plasma discharges
- Analysis of H content using ERDA
- → Goal: Determination of neutral charge-exchange H-fluxes

- Exposure of erosion samples with midplane manipulator during plasma discharges
- Aluminium coated with 7 or 30 nm a-C:D
- $\rightarrow$  Goal: Erosion of C by charge-exchange H-fluxes

## Samples inside W7-X in OP2.1 and 2.2

#### **Erosion of W at inner heat shield**

- 18 inner heat shield tiles coated with W / 600 nm Mo / 100 nm W marker
- W marker layer thicknesses pre-characterized with RBS

#### Goals

- Erosion of W at inner heat shield
- Deposition of B, C

#### Deposition of B and C on baffle and inner wall

- Analysis of regular C baffle and inner wall tiles after OP2.1 and/or OP2.2
- Analysis with RBS (NRA if necessary, SEM/FIB if necessary)

#### Goals

- Deposition of H, B, C

